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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *TN*  
 This application is a CIP of 10/459,943 06/12/2003

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 REPUBLIC OF KOREA 04-7104 02/04/2004

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>TN</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 6	TOTAL CLAIMS 54	INDEPENDENT CLAIMS 3
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TITLE  
 Method for forming silicon dioxide film using siloxane

☐ All Fees